



(JES)² = (JSS)(JES)

The Electrochemical Society (ECS) has a long history of archival technical publishing, beginning in 1902 when the Society was formed, wherein a record of the papers presented at Society meetings was published as *Transactions of the American Electrochemical Society*. ECS has published articles in both electrochemical and solid state science and technology in one full-papers journal, *Journal of The Electrochemical Society* (JES), since 1948. Beginning with this issue, two full-papers journals have evolved from JES. The two journals are *ECS Journal of Solid State Science and Technology* (JSS), focusing on solid state topics, and a re-formulated JES that focuses on electrochemical science and technology. This action was taken to better serve our authors, readers and the scientific and engineering communities, by making available separate journals that focus on the two general technical areas represented by ECS. I am serving as the editor of JSS and JES is edited by Petr Vanýsek.

In order to facilitate and shorten the review and publication cycle and to ensure effective coverage of the topical technical areas of JSS, an expanded and separate Editorial Board has been established for JSS and *ECS Solid State Letters* (SSL). JSS and SSL are full-paper and letter journals, respectively, that cover the solid state focus areas for ECS journals. Specifically, the technical interest areas (TIAs) that describe the scope of ECS journals and the Technical Editors who oversee the evaluation of manuscripts submitted in these TIAs are: Electronic Materials and Processing (Jennifer Bardwell), Dielectric Science and Materials (Stefan DeGendt), Carbon Nanostructures and Devices (Francis D'Souza), Electronic and Photonic Devices and Systems (Yue Kuo.), Luminescence and Display Materials, Devices and Processing (Kailash Mishra) and Physical Sensors (Rangachary Mukundan). We continue to utilize the expertise of our Editorial Advisory Committee to rapidly assess manuscripts and offer insightful feedback to authors and editors. More details regarding the restructuring of ECS journals can be found in the spring, 2012 issue of *Interface*, beginning on p. 18.

In order to offer enhanced technical content to readers of ECS journals, JSS will publish several special issues each year. These will be focused on topical areas that are especially timely and critical to the advancement and development of solid state science and technology, and will be in addition to the twelve monthly issues of JSS.

The launching of new journals is a gargantuan task that would not have been possible without the dedication and extensive work of a large number of people. First, the ECS Technical Interest Areas Task Force, chaired by Bill Brown, put in countless hours to ensure that the technical scope and focus of our (now) four journals are appropriate for current and future directions of the Society. Task Force efforts were coordinated and assisted enormously by several ECS Headquarters staff members. In particular, Mary Yess, ECS Deputy Executive Director and Publisher, Ann Goedkoop, ECS Director of Publications, and Paul Cooper, ECS Editorial Manager, directed and implemented the numerous changes that ECS Journals have undergone over the past year; without their tireless efforts, this publishing transformation would not have been possible, especially over a very short period of time.

As we begin this new phase for ECS journals, I want to thank the many authors, reviewers and readers for their diligence and hard work to ensure quality publications. We look forward to your continued support and advice as we undertake our new responsibilities for four journals. We also seek your input regarding how we can continue to improve the quality, timeliness and significance of ECS solid state journals. Please contact me at dennis.hess@chbe.gatech.edu with your suggestions and comments. Thanks for taking part in and contributing to the new ECS journals and the future of the Society.



Dennis W. Hess
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Editor